



AP/ 2815

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 1107

Jung Chuan CHOU, et al.

Art Unit: 2815

Serial No.: 09/533,591

Examiner: E. Ortiz

Filed: March 23, 2000

Docket No.: H000010

For: **A-WO₃-GATE ISFET DEVICES AND METHOD OF MAKING THE SAME**

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 10, 2003

Dear Sir:

In response to the Office Action dated September 8, 2003 (hereinafter "outstanding Action"), and within the two-month time period of the mailing date of the final action, said time period ending on November 8, 2003 and falling on a Saturday, please reconsider the above-identified application based on the following amendments, which follow a revised format under 37 C.F.R. §1.121:

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